

Electronic Acknowledgement Receipt

EFS ID:	1974120
Application Number:	10593857
International Application Number:	
Confirmation Number:	5813
Title of Invention:	Plasma Chamber Having Plasma Source Coil and Method for Etching the Wafer Using the Same
First Named Inventor/Applicant Name:	Nam Hun Kim
Customer Number:	23363
Filer:	D. Bruce Prout/Vickie Wall
Filer Authorized By:	D. Bruce Prout
Attorney Docket Number:	58409/N305
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Application Type:	U.S. National Stage under 35 USC 371

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Miscellaneous Incoming Letter	58409_Small_Entity_Statement.pdf	80384 110e9e4c9d51012488f3a5d11ba351234d83a1e	no	2

Warnings:

Information:					
2	Miscellaneous Incoming Letter	58409_Submission_of_Small _Entity_Declaration.pdf	28896 d20cd7617ab09a364213b0ce587b402b 5d8ec9d9	no	1
Warnings:					
Information:					
Total Files Size (in bytes):			109280		
<p>This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.</p> <p><u>New Applications Under 35 U.S.C. 111</u> If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.</p> <p><u>National Stage of an International Application under 35 U.S.C. 371</u> If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p> <p><u>New International Application Filed with the USPTO as a Receiving Office</u> If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.</p>					